

<b>Notice of References Cited</b>	Application/Control No. 10/583,536		Applicant(s)/Patent Under Reexamination CHO, JA YEON	
	Examiner MARTIN ROGERS		Art Unit 1791	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,038,006	07-1977	Farrell, John J.	425/525
*	B	US-3,817,390	06-1974	Maruniak et al.	210/460
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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